

**Notice of References Cited**

Application/Control No.

10/065,296

Applicant(s)/Patent Under  
Reexamination  
LIN ET AL.

Examiner

Yennhu B Huynh

Art Unit

2813

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**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-6448101	09-2002	Kuo et al.	438/45
	B	US-2003/0085415A1	05-2003	Chen et al.	257/232
	C	US-6611037B1	08-2003	Rhodes	257/466
	D	US-6534335	03-2003	Rhodes et a.	438/60
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	I	US-			
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	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
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**NON-PATENT DOCUMENTS**

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